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## IN THE UNITED STATES PATENA AND TRADEMARK OFFICE

In re Patent Application of

IMAI ET AL.

Serial No. 10/589,390

Filed:

August 15, 2006

APR 10 2007

Atty. Ref.:

1035-650

Group:

2812

Examiner:

Unknown

For:

Thin Film Transistor, Method of Manufacturing Same, Display Device, Method Of Modifying An Oxide Film, Method of Forming An Oxide Film, Semiconductor Device, Method of Manufacturing Semiconductor Device, and Apparatus For

Manufacturing Semiconductor Device

All listed documents are attached

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **INFORMATION DISCLOSURE STATEMENT**

As suggested by 37 C.F.R. 1.97, the undersigned attorney brings to the attention of the Patent and Trademark Office the references listed on the attached form PTO-1449.

$\boxtimes$	This application was filed after June 30, 2003 so that copies of U.S. Patent
Publication	ns are not required and are not attached.

☐ Listed foreign patent publications and other documents are enclosed.

The partial translations were provided to the undersigned by the applicants' foreign representative. The undersigned has no knowledge regarding the pertinency of the partially translated portions vis-á-vis the document as a whole. The partial translations are merely provided for whatever convenience they may be.

☑ U.S. Publication 2003/0102793 corresponds to the JP 2003-133309 reference cited in the specification; U.S. Publication 2005/0215070 corresponds to the JP 2004-047935 reference cited in the specification; and U.S. Patent 6,221,788 corresponds to the JP 09-045679 reference cited in the specification.

This is not to be construed as a representation that a search has been made or that no better prior art exists, or that a reference is relevant merely because cited.

The Examiner is requested to initial the attached form PTO-1449 and to return a copy of the initialed document to the undersigned as an indication that the attached references have been considered and made of record.

The Commissioner is authorized to charge the undersigned's deposit account #14-1140 in whatever amount is necessary for entry of these papers and the continued pendency of the captioned application.

By:

Respectfully submitted, NIXON & VANDERHYE P.C.

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H. Warren Burnam, Jr. Reg. No. 29,366

April 10, 2007

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## Sheet

## INFORMATION DISCLOSURE **CITATION**

ATTY. DOCKET NO

1035-650 **APPLICANT** 



SERIAL NO.

10/589,390

IMAI ET AL.

(Use several sheets if necessary)

FILING DATE

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		L	J.S. PATENT DOCUMENTS				
EXAMINER		5.475	=			FILING	
INITIAL	DOCUMENT NUMBER 2003/0102793	DATE 6-2003	NAME Komoda et al.	CLASS	SUBCLASS	<u>IF APPRO</u> I	OPRIATE
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Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)